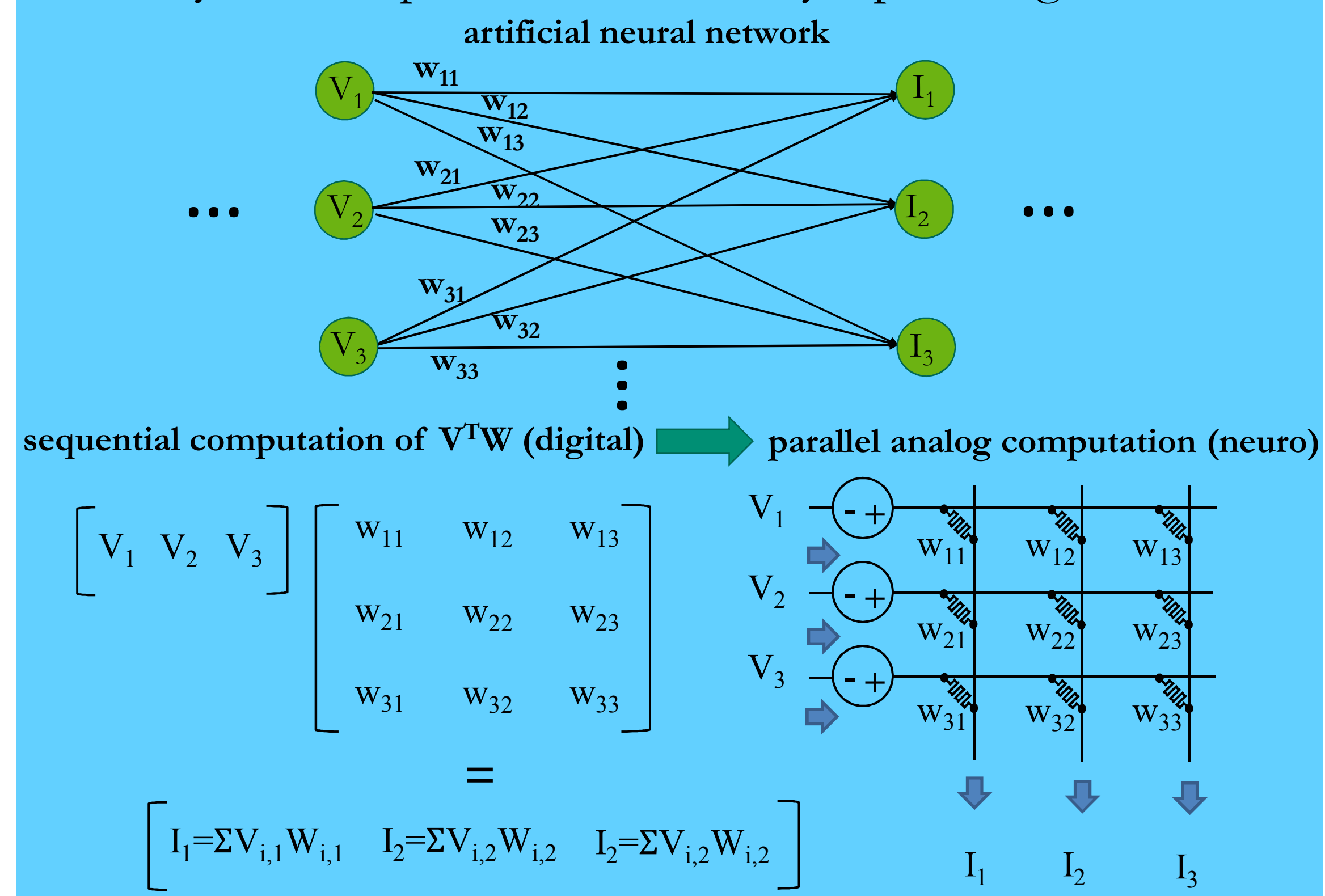


# Ionic floating-gate memory for neuromorphic computing

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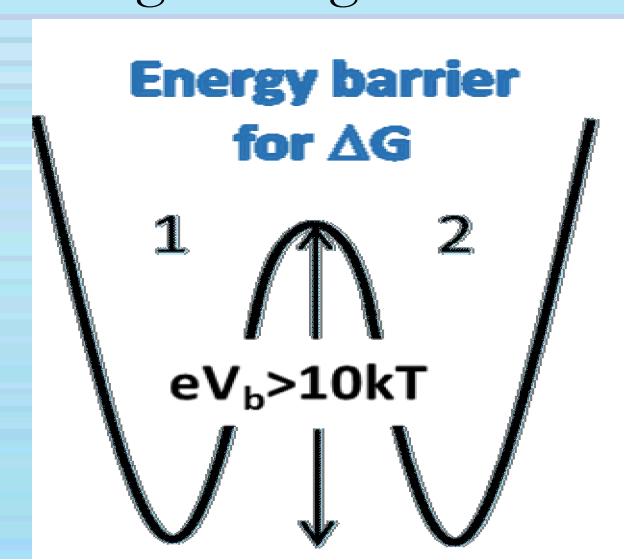
Neuromorphic computers can overcome efficiency bottlenecks inherent to digital computers by using analog memory to both process and store synaptic weights.



Resistive random access memory (RRAM) that is proposed for neuromorphic computers suffers from large voltages and currents that prevent scaling to large arrays.

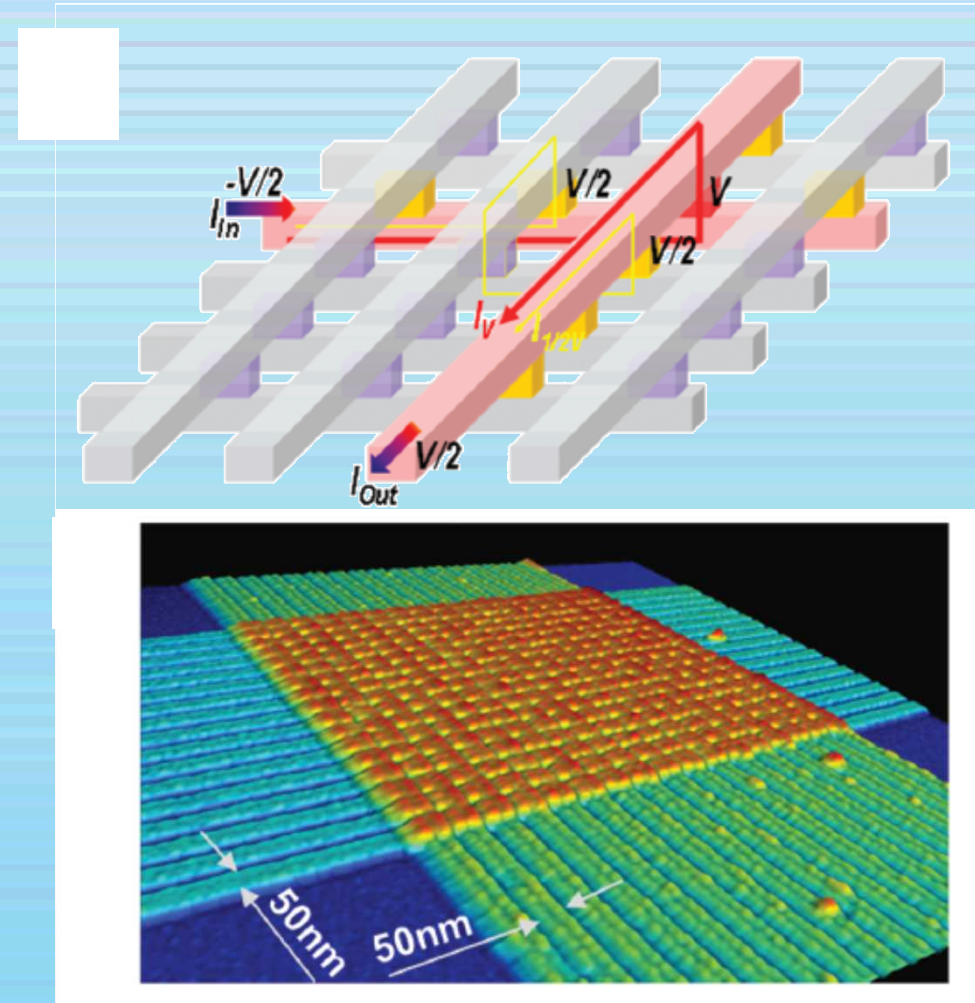
**RRAM time-voltage dilemma:** For two-terminal devices, a large energy barrier between conductance states is needed for retention but leads to large voltages and currents.

**Parasitic losses** limit working neuromorphic arrays to  $\sim 100 \times 100$ . Arrays  $> 1000 \times 1000$  are needed to average out cost of circuit overheads for high energy efficiency.



Schroeder et al. *Journal of Applied Physics* (2010)

**Large voltages and currents** lead to parasitic losses within an array that inhibit programming.



Yang et al., *Applied Physics Letters*, 100, 113501 (2012)

Ionic floating-gate memory (IFG) can meet important requirements for a neuromorphic computer with  $10^5$  energy efficiency gain over existing CPUs and  $10^3$  gain over GPUs.

- low voltages ( $< 700\text{mV}$ ) and low currents ( $< 5\text{nA}$ ) for scaling to arrays  $> 1000 \times 1000$
- linear programmability required for massively parallel “blind” updates (outer-product update)
- array level selectivity and retention

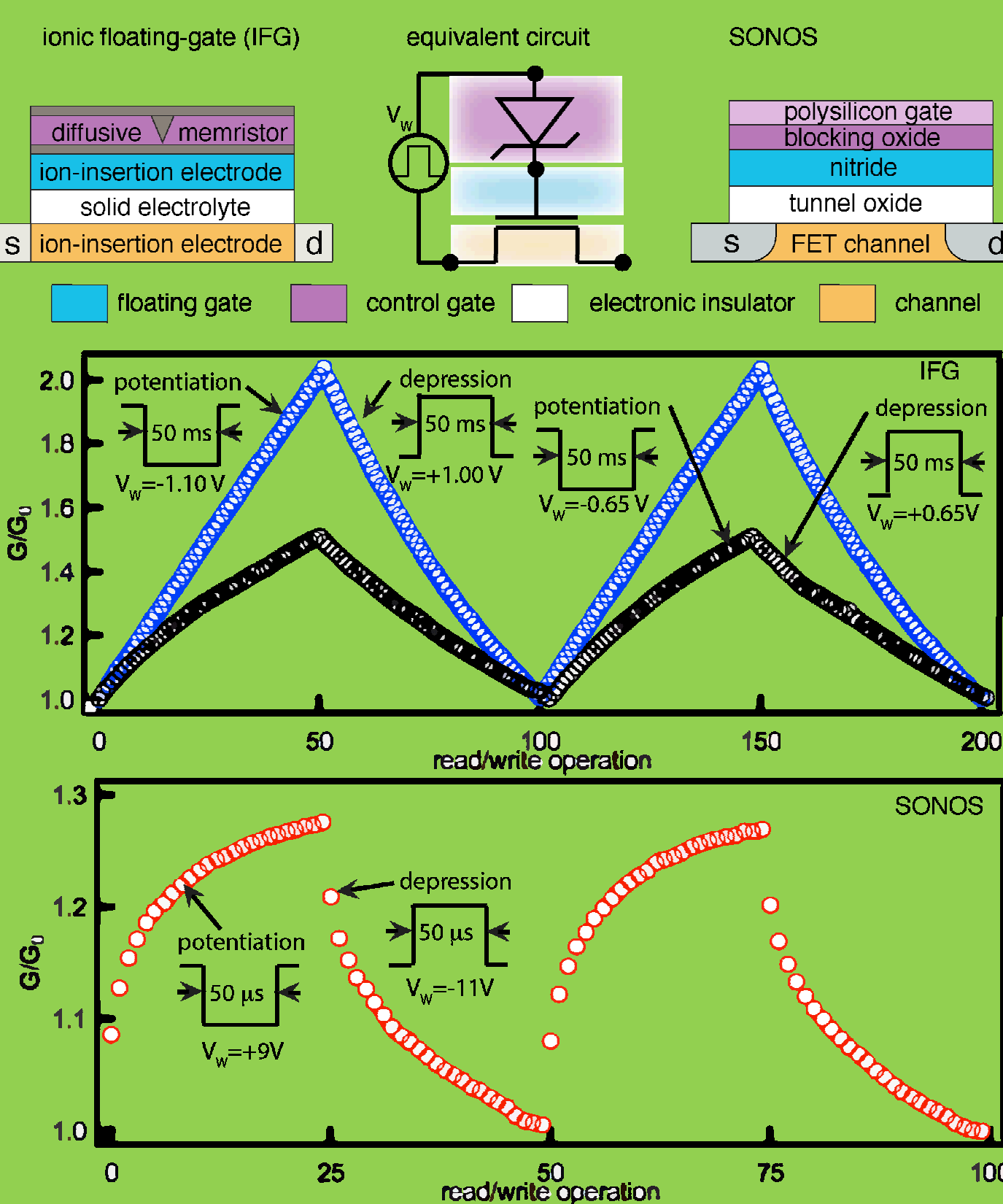
A redox transistor composed of ion-insertion electrodes (blue, orange) and a solid electrolyte (white) is used to store the analog states

A threshold device (purple), such as a diffusive memristor is used as a control gate.

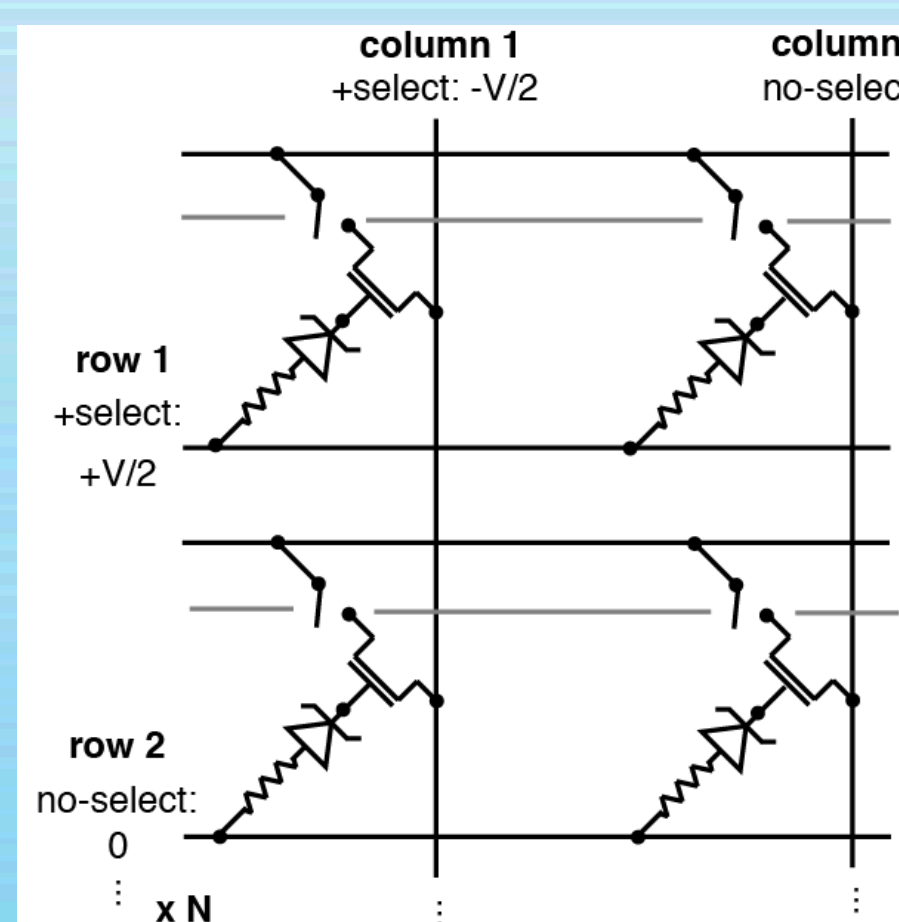
**Operational similarity** to CMOS floating gate memory (e.g. SONOS, FLASH) but with an order of magnitude lower programming voltage.

**RRAM time-voltage dilemma** is circumvented with a third terminal used for programming and memory read out from source and drain terminals. This allows low voltages and currents with long retention times.

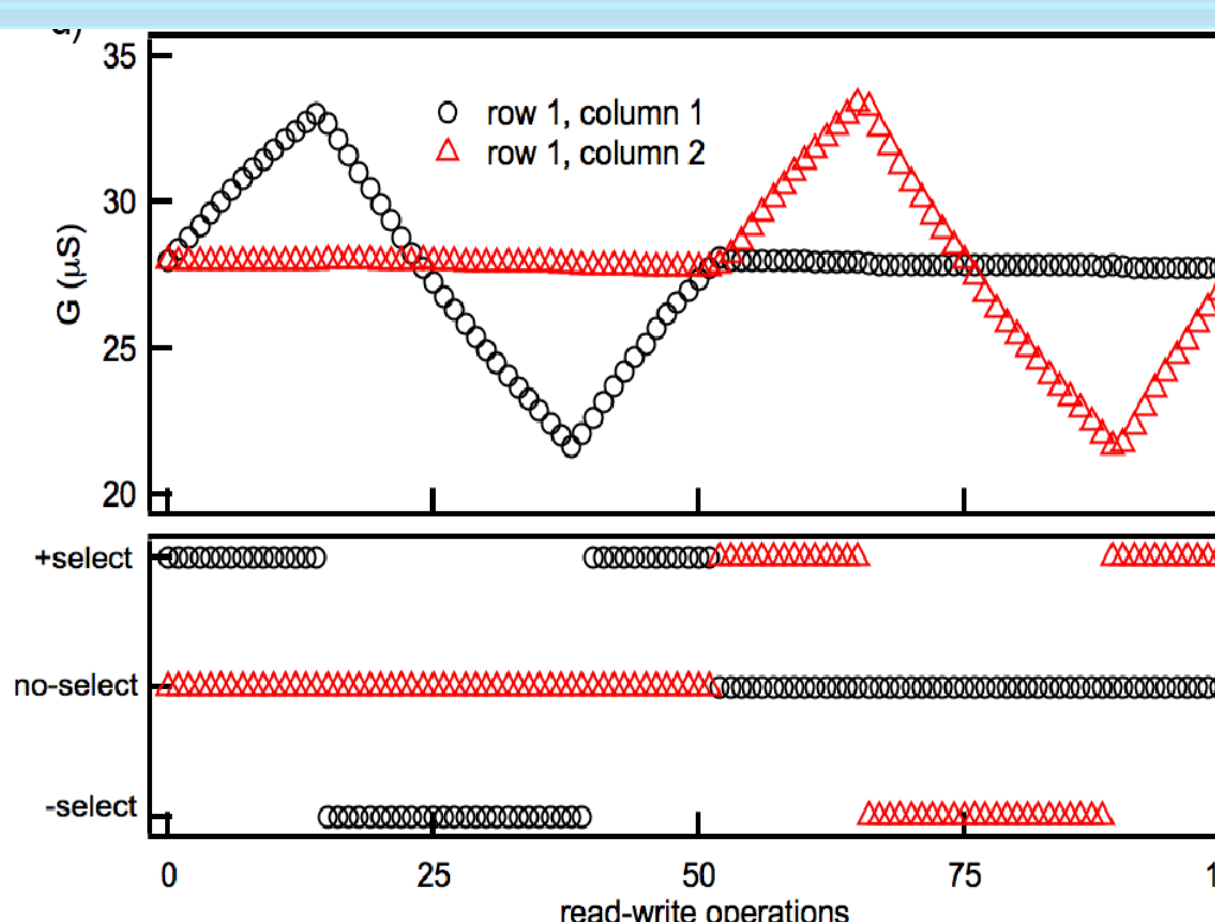
**Linear Tuning:** IFG has linear programmable levels while SONOS and RRAM do not.



IFG crossbar circuit-level schematic is shown with outer-product operation.



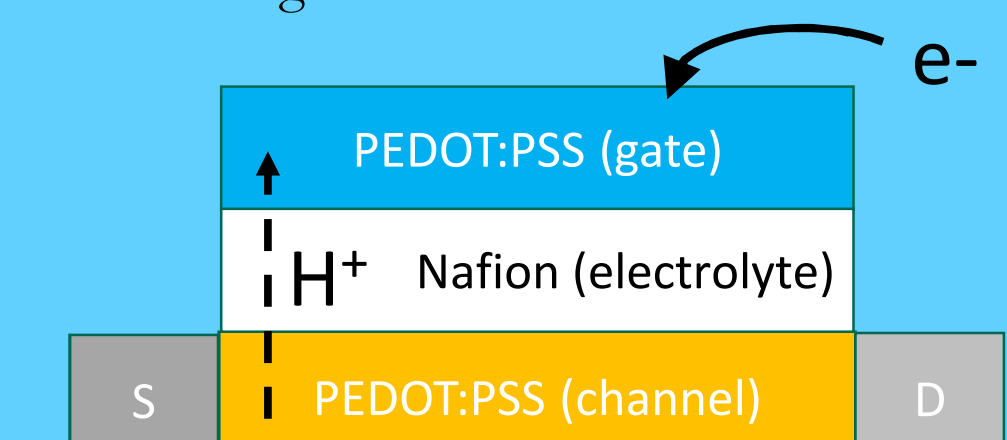
Prototype IFG crossbar array (1x2) with selective writes to element (1,1) and (1,2).



IFG uses entirely ion-based switching mechanisms in order to achieve low voltages and high performance.

**Redox transistor to store weights:**

In order to switch the channel resistance, charge is needed to drive ion exchange between the gate and channel in a charge-limited redox reaction.



**PEDOT:PSS** is a redox-active polymer blend that undergoes a charge compensation reaction after proton insertion that generates hole carriers.

**Nafion** is a solid electrolyte with a high proton diffusivity.

**Low voltages** ( $< 100\text{mV}$ ) can switch a redox transistor state. Floating gate accrues minimal voltage ( $< 50\text{mV}$ ) due to high accumulation capacitance.

**Large arrays**  $> 1000 \times 1000$  can be realized through doping PEDOT:PSS channels to  $> 100\text{M}\Omega$ .

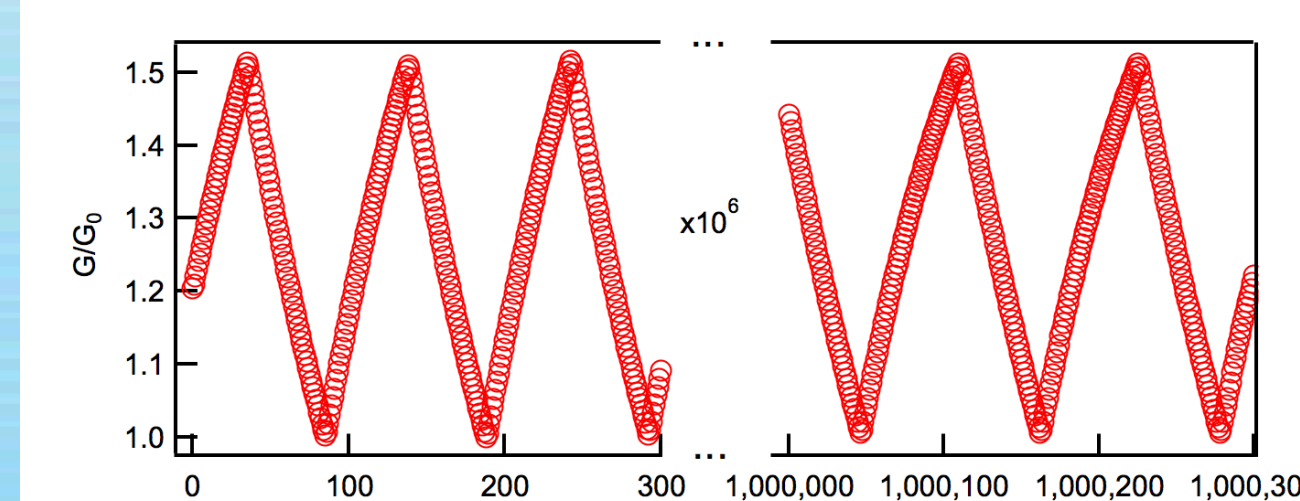
**Leakage** requirements are relaxed due to  $10^3$  higher charge density per analog level for ion-insertion electrodes compared to an FET channel.

**Material versatility:** redox transistors can be made with transition metal oxides and ceramic electrolytes

van de Burgt et al., *Nature Materials*, 16(4), 2017

Fuller et al., *Advanced Materials*, 29(4), 2017

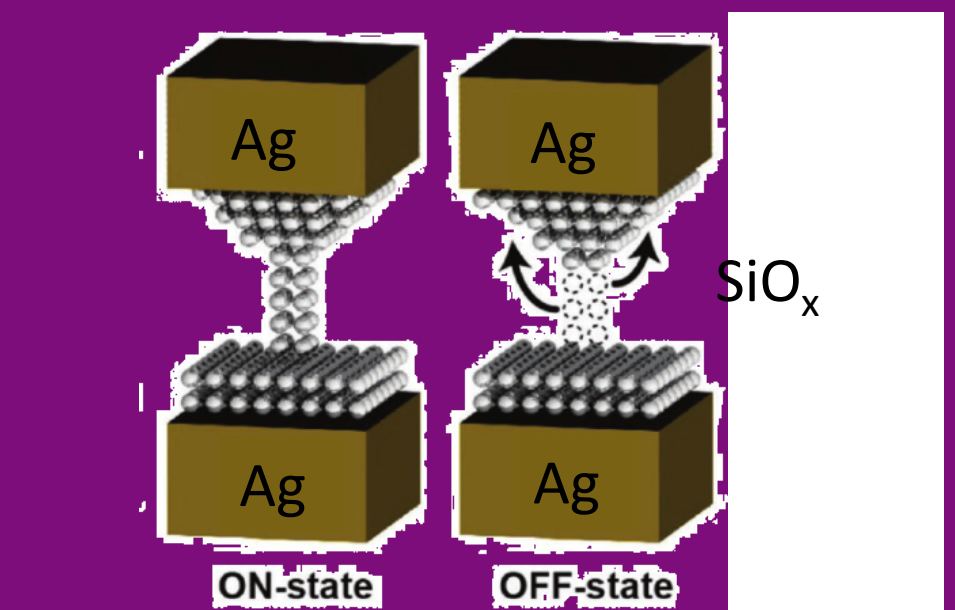
**Endurance** of a redox transistor reaches  $10^6$  write operations without degradation. Diffusive memristors have been demonstrated with endurance as high as  $10^8$ .



**Future work:** faster switching speeds  $> 1\text{MHz}$ , endurance  $10^{13}$ , and CMOS integration must be demonstrated.

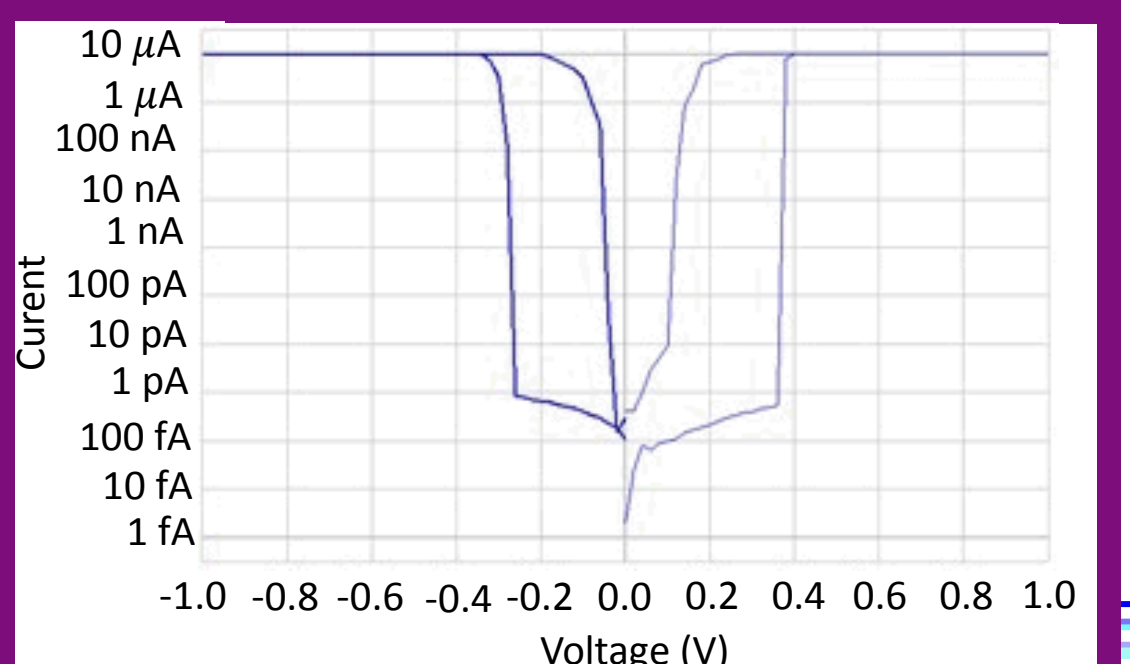
**Diffusive memristor as control gate:**

This volatile threshold switch is normally in the OFF state to prevent charge from entering the redox transistor gate in order to preserve the memory state.



Pt/Ag/SiO<sub>x</sub>/Ag/Ag/Pt

Once a small voltage threshold ( $\pm 400\text{mV}$ ) is reached, the memristor turns to the ON state allowing the redox transistor to be programmed. A large ON/OFF ratio ensures long retention times. A fast filament dissolution time (150 ns) can support fast redox transistor programming times.



Midya et al., *Advanced Materials*, 29(12), 2017

**Neural network simulation** of IFG crossbar achieves ideal accuracy in backpropagation.

